

500.41374CX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): S. KANNO, et al  
Serial No.: (not yet assigned)  
Filed: September 10, 2003  
For: WAFER STAGE FOR WAFER PROCESSING APPARATUS  
AND WAFER PROCESSING METHOD

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 10, 2003

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment to the Title; and

Remarks are included following the amendments.